

Application Serial No. 10/583,018
Reply to Non-Final Office Action of April 29, 2008

PATENT
Docket: CU-4878

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Amendments to the Abstract

Please replace the Abstract with the following amended Abstract:

~~The object of the invention is to provide a~~ A highly reliable organic functional element such as an organic EL element or an organic semiconductor element ~~exemplified by an organic TFT element which~~ that can be manufactured without requiring a vapor deposition process for forming an electrode on an organic material layer. ~~Consequently, such~~ Such an organic functional element can be large-sized easily and produced at lower cost. ~~In addition, no damage is caused to the organic material layer during formation of the electrode, and the organic functional element is not affected by environmental changes.~~ Additionally, there is no damage to the organic material layer during its formation and it is not affected by environmental changes. ~~Also disclosed is a method for manufacturing such an organic functional element. To attain the above-mentioned objective, the present invention provides and~~ The organic functional element comprising includes at least a plurality of electrodes and an organic material layer ~~which is characterized in that at~~ At least one of the electrodes is composed of a metal having a melting point ~~not higher than a temperature that is higher by 30°C than the glass transition temperature of the organic material layer~~ no higher than 30°C above the glass transition temperature of the organic material layer.